

PATENT APPLICATION Docket No. 11675.107

#25/F Fond + J. Manullan t Unit 3/11/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

David Y. Kao et al.

Serial No.:

08/720,693

Filed:

October 2, 1996

For:

OXIDATION OF ION IMPLANTED

SEMICONDUCTORS

Examiner:

George R. Fourson III

AMENDMENT AND RESPONSE

Commissioner for Patents Washington, D.C. 20231

Sir:

In response to the Office Action mailed from the United States Patent and Trademark Office on November 20, 2002, please enter the following amendments and remarks into the file of the above-identified application.

IN THE CLAIMS:

Please amend the claims as follows: